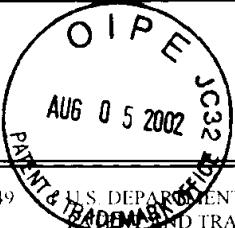


EXAMINER Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

* See Paper 14



#14
SHEET 1 OF 6

FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT & TRADEMARK OFFICE		DOCKET: 002813 USA D01/ETCH/SILICON/JB			APPLICATION NO. 09/610,237	
INFORMATION DISCLOSURE STATEMENT IN AN APPLICATION (Use several sheets if necessary)		APPLICANT: GRIMBERGEN, et. al				
		FILING DATE 07/05/2000			GROUP ART UNIT 1763	
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>AN</i>	5,322,390	06/21/1994	KOSHIMIZU			
<i>AN</i>	5,759,424	06/02/1998	IMATAKE et al	216	60	
<i>AN</i>	6,207,008	03/27/2001	KIJIMA	156	626.1	
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
						YES
<i>AN</i>	11176815	07/02/1999	JAPAN			X
<i>AN</i>	WO 99/65056	12/16/1999	PCT			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)						
<i>AN</i>	PCT SEARCH REFERENCE FROM INTERNATIONAL APPLICATION NO. PCT/US 01/29802, MAILED ON 02/05/2002.					
EXAMINER: <i>AN</i>						DATE CONSIDERED: <i>12/14/02</i>
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.						

* See- IDS of 7/5/00 (Part #2)